

UNITED STATES PATENT AND TRADEMARK OFFICE
CERTIFICATE OF CORRECTION

PATENT NO. : 6,830,652 B2
DATED : December 14, 2004
INVENTOR(S) : Tadahiro Ohmi et al.

Page 1 of 1

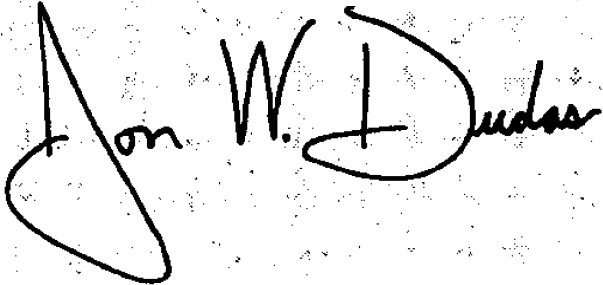
It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

Title page,

Item [54], Title, replace "MICROWAVE PLASMA PROCESSING APPARATUS"
with -- PLASMA PROCESSING APPARATUS --.

Signed and Sealed this

Seventh Day of June, 2005

A handwritten signature in black ink, reading "Jon W. Dudas", is enclosed within a rectangular border. The signature is written in a cursive style with a large initial "J".

JON W. DUDAS

Director of the United States Patent and Trademark Office